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			Application Number	Not yet assigned 10/825,800
			Filing Date	On even date herewith 4/14/04
			First Named Inventor	Darrin Leonhardt
			Group Art Unit	Not yet assigned 1753
			Examiner Name	Not yet assigned Ver Steeg
Sheet 1	of 2	Attorney Docket Number	95,876	

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August 8 2015

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Substitute for form 1449B/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	Not yet assigned 12825200
		Filing Date	On even date herewith 4/14/04
		First Named Inventor	Darrin Leonhardt
		Group Art Unit	Not yet assigned 1753
		Examiner Name	Not yet assigned VerSteg
		Attorney Docket Number	95,876
Sheet 2	of 2		

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
SHV		U.S. Patent Application 10/644,567 entitled "Electron Beam Enhanced Large Area Deposition System" filed on August 20, 2003 by Scott G. Walton et al.	
SHV		U.S. Patent Application 10/672,269 entitled "Method and Apparatus for Producing an Ion-Ion Plasma Continuous in Time" filed on September 26, 2003 by Richard F. Fernsler et al.	
SHV		R. F. FERNSLER ET AL., "Production of large-area plasmas by electron beams," Phys. Plasmas, 1998, 5, 2137-2143	
SHV		WALLACE M. MANHEIMER ET AL., "Theoretical overview of the large-area plasma processing system (LAPPS)," Plasma Sources Sci. Technol. 2000, 9, 370-386	
SHV		S. G. WALTON ET AL., "Ion energy distributions in a pulsed, electron beam-generated plasma," J. Vac. Sci. Technol. A, 2001, 19(4), 1325-1329	
SHV		D. LEONHARDT ET AL., "Plasma diagnostics in large area plasma processing system," J. Vac. Sci. Technol. A, 2001, 19(4), 1367-1373	
SHV		R. A. MEGER ET AL., "Beam-generated plasmas for processing applications," Phys Plasmas, 2001, 8, 2558-2564	
SHV		DARRIN LEONHARDT, "Electron-Beam Produced Plasmas: Considerations and Applications," Vacuum Technology & Coating, November 2001, 24-35	
SHV		D. LEONHARDT ET AL., "Generation of electron-beam produced plasmas and applications to surface modification," Surface and Coatings Technology, 2004, 177-178, 682-687	

Examiner Signature		Date Considered	August 9, 2005
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¹ EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.

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